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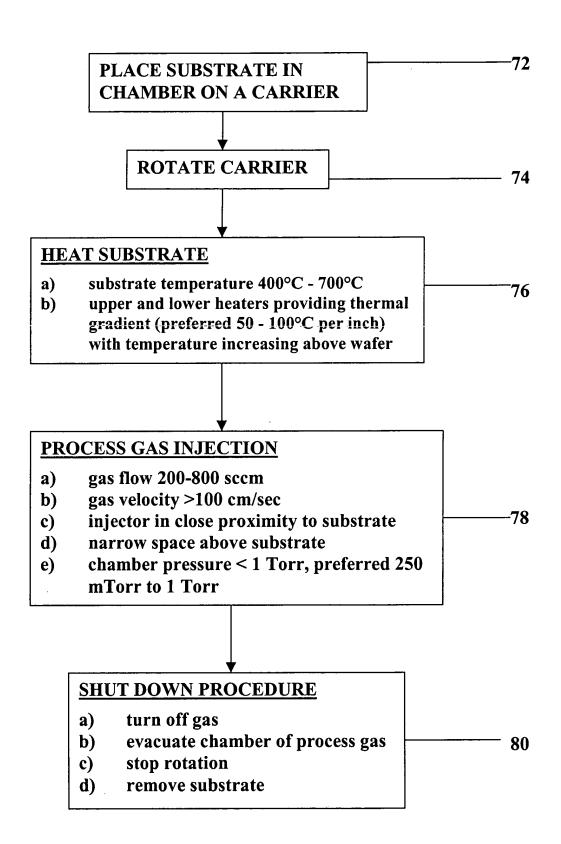
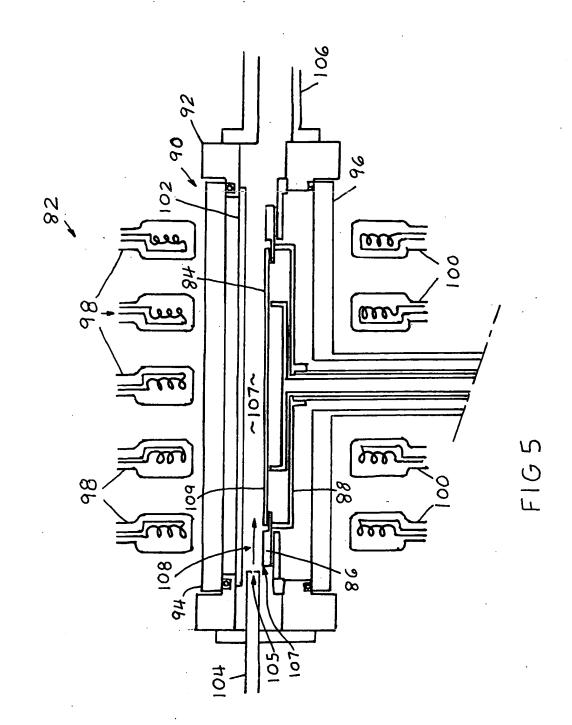


FIG. 4



Deposition Rate vs Temperature

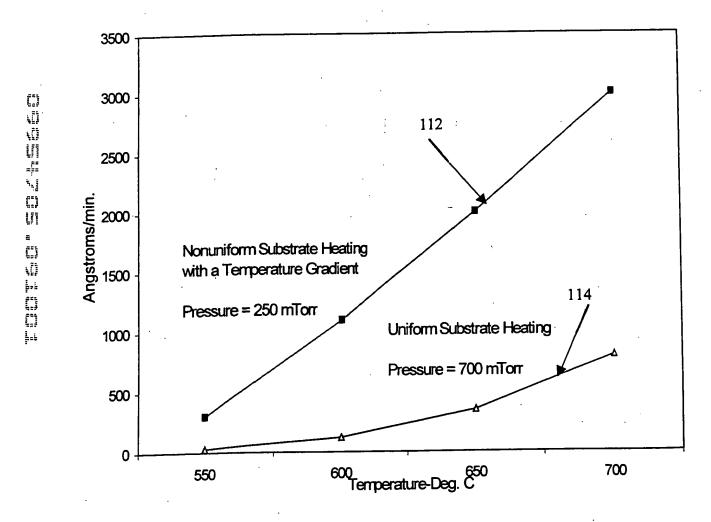


Figure 6

Silicon Deposition Rate vs Silane Flow with Non-uniform Substrate Heating

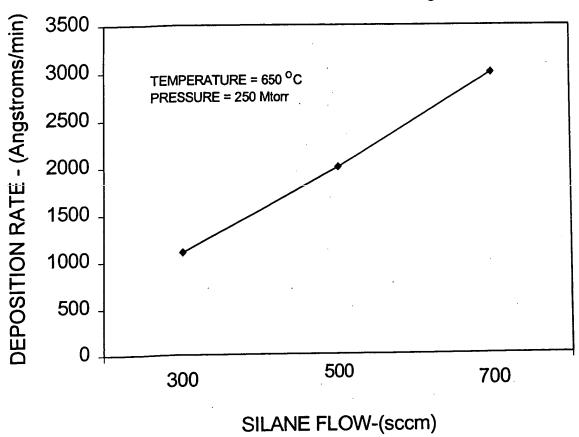
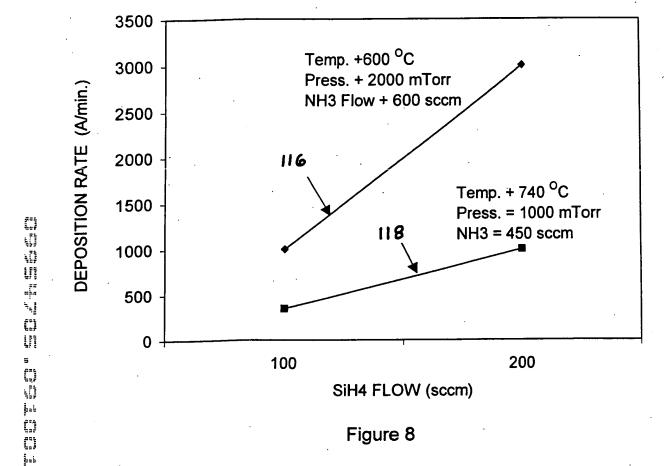


Figure 7



Silicon Nitride Deposition Rate versus Pressure

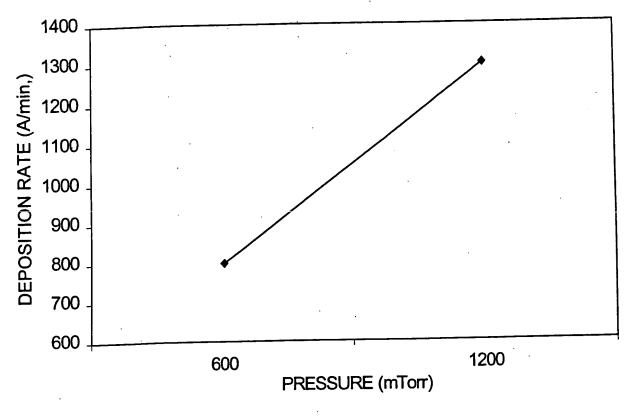


Figure 9